## <u>E UNITED STATES PATENT AND TRADEMARK OFFICE</u>

In re Application

Inventors:

DeOrnellas, et al.

SC/Serial No.:

10/045,318

Confirm. No.:

3120

Filed:

November 9, 2001

Title: METHOD FOR USING A HARD MASK FOR

CRITICAL DIMENSION GROWTH

**CONTAINMENT** 

PATENT APPLICATION

Art Unit:

1765

Examiner:

L. Umez Eronini

Customer No. 23910

## CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November

3, 2003.

Thomas A. Ward, Reg. 35,732 Signature Date: November 3, 2003

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111

Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office Action mailed August 1, 2003, please amend the above-identified application as follows.

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